

AM-FPD '11 Time Table

	Monday, July 11		Tuesday, July 12		Wednesday, July 13	
Registration	8:30-17:00		8:30-17:00		8:30-15:00	
Tutorial	9:00-11:00	<i>Tutorial in Japanese</i>				
Workshop			9:00-10:30	Symposium(1) : Carrier Transport in Si, Oxide and Organic Thin Films	9:20-10:20	Session 4 : Thin-Film Materials and Processing
	11:10-11:25	Opening Session	10:30-10:45	<i>Coffee Break</i>	10:20-10:35	<i>Coffee Break</i>
	11:25-12:25	Session 1 : Keynote Address	10:45-12:00	Special Session : Next Generation Thin Film Technologies for Photovoltaics	10:35-12:00	Session 5 : Silicon and Organic Thin-Film Transistors
	12:25-13:45	<i>Lunch</i>	12:00-13:30	<i>Lunch</i>	12:00-13:30	<i>Lunch</i>
	13:45-15:15	Session 2 : Novel Technologies for FPD	13:30-14:30	Symposium(2) : Advanced Technologies for Thin and Flexible Displays	13:30-15:00	Session 6 : Photo Sensors and Sollar Cells
	15:15-15:30	<i>Coffee Break</i>	14:30-14:45	<i>Coffee Break</i>	15:00-15:15	<i>Coffee Break</i>
	15:30-16:55	Session 3 : Oxide Thin-Film Transistors (I)	14:45-16:15	Symposium(3) : Current Status and Development Trends in Carbon Based Devices	15:15-16:00	Session 7 : Oxide Thin-Film Transistors(II)
	16:55-17:10	Late News	16:15-16:25	<i>Coffee Break</i>	16:00-16:15	Late News
Author Interviews	17:20-17:50	Author Interviews	16:25-16:55	Author Interviews	16:25-16:55	Author Interviews
Poster Session			16:25-18:25	Poster Session : FPD _p / TFT _p / TFMD _p / LN _p		
Banquet	18:15-20:15	<i>Banquet</i>				

Workshop : “RyukokuUniversity Avanti Kyoto Hall”(Avanti, 9th Floor)

Registration : Entrance (Avanti, 9th Floor)

Poster Session : Lobby (Avanti, 9th Floor)

Author Interviews : Lobby (Avanti, 9th Floor)

Banquet : Mariage Grande “Takao”(Avanti, 8th Floor)

Tutorial : “RyukokuUniversity Avanti Kyoto Hall”(Avanti, 9th Floor)